



06-16-06

EQ 353764520 US

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Lee, Wai M. et al.

Application No.: 10/694,999

Confirmation No.: 5303

Group Art Unit: 1763

Filed: October 29, 2003

Examiner: K. Moore

For: *Apparatus for Substrate Pre-Treatment*

Attorney Docket No.: 63702-226US  
(formerly 60937-226US)

RESPONSE TO RESTRICTION/ELECTION REQUIREMENT

Mail Stop: Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Examiner:

Please change the attorney docket number to 63702-226-US. Future correspondence should be forwarded to James S. McDonald, customer no. 24341.

Petition for Extension of Time under 37 CFR 1.136. It is respectfully requested that the time for response to the Office Action dated December 14, 2005 be extended for a period of 5 months from January 14 to June 14, 2006.

The Commissioner is hereby authorized to charge any required fee(s) to Morgan, Lewis & Bockius LLP Deposit Account No. 50-0310 (order no. 63702-226US). A copy of this sheet is enclosed for such purpose.

Other than this extension fee, it is Applicants' understanding that no other fee is due at this time, however, the Commissioner is authorized to charge any fees associated with this communication to Morgan, Lewis & Bockius LLP Deposit Account No. 50-0310 (Order No. 63702-226US). A copy of this sheet is enclosed for such purpose.

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